Electronic Acknowledgement Receipt		
EFS ID:	1397648	
Application Number:	10771986	
International Application Number:		
Confirmation Number:	3566	
Title of Invention:	Catadioptric projection system for 157 nm lithography	
First Named Inventor/Applicant Name:	Russell Hudyma	
Customer Number: 7278		
Filer:	Jay Philip Lessler/Lillian Garcia	
Filer Authorized By:	Jay Philip Lessler	
Attorney Docket Number:	01641/100K021-US5	
Receipt Date:	22-DEC-2006	
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Time Stamp:	16:36:11	
Application Type:	Utility	

Payment information:

	Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1		00953409.pdf	83388	yes	10

	Multipart Description/PDF files in .zip description		
	Document Description	Start	End
	Miscellaneous Incoming Letter	1	1
	Amendment After Final	2	2
	Claims	3	8
	Applicant Arguments/Remarks Made in an Amendment	9	10
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Warnings

Information:

Total Files Size (in bytes): 83388

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.